



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jay Schwichtenberg et al.

Serial No.: 10/612,664

Examiner: unknown

Filing Date: July 2, 2003

Group Art: unknown

For: METHOD AND APPARATUS FOR RECEIVING A REMOVABLE MEDIA
MEMBER

Docket No.: H26922 formerly H0003695 (1100.1187101)

TRANSMITTAL SHEET

Assistant Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

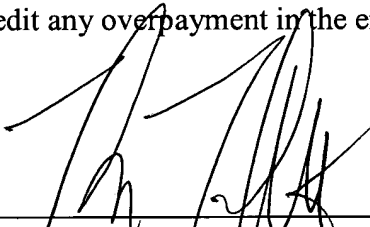
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By: _____

Brian N. Tufte

We are transmitting herewith the attached:

- [X] Information Disclosure Statement, Form PTO-1449 and 161 cited references.
[X] Please charge any deficiencies or credit any overpayment in the enclosed fees to Deposit Account No. 50-0413.



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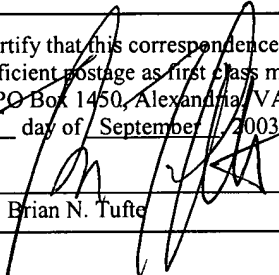
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INFORMATION DISCLOSURE STATEMENT (37 C.F.R. §1.97(b))

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on this 2nd day of September, 2003

By: 
Brian N. Tufts

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner.

This statement should be considered because it is submitted before the mailing date of a first Office Action on-the-merits. Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F. R. §1.98(a)(2), a copy of each document or other information listed on the enclosed Form 1449 is provided.

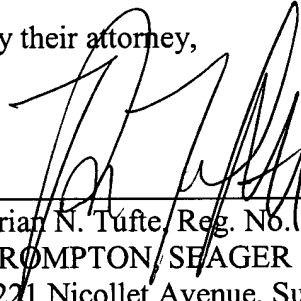
No representation is intended to be made hereby that any of the cited references establishes, by itself or in combination with other information, a prima facie case of unpatentability of any claim of the present case.

Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

Respectfully submitted,

Jay Schwichtenberg et al.

By their attorney,

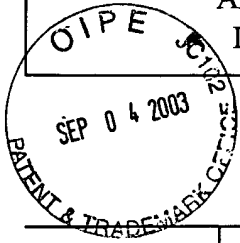


Dated: September 2, 2003

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10/612,664LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

Applicant: Jay Schwichtenberg et al.

Filing Date:
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unknown**U.S. PATENT DOCUMENTS**

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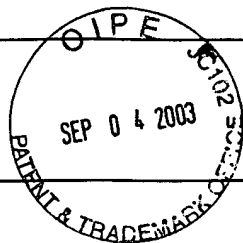
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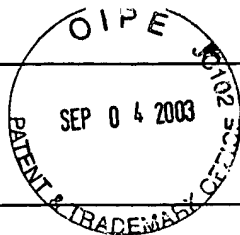
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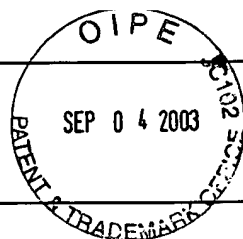
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	DE 19617852	01/1993	DE	Abstract
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EXAMINER:	DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.